# 505653878 09/04/2019

# PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT5700684

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
YANG BEOM KANG	08/27/2019
KANG SUP SHIN	08/26/2019

## **RECEIVING PARTY DATA**

Name:	MAGNACHIP SEMICONDUCTOR, LTD.		
Street Address:	215, DAESIN-RO, HEUNGDEOK-GU, CHUNGCHEONGBUK-DO		
City:	CHEONGJU-SI		
State/Country:	KOREA, REPUBLIC OF		
Postal Code:	28429		

# **PROPERTY NUMBERS Total: 1**

Property Type	Number	
Application Number:	16560147	

## **CORRESPONDENCE DATA**

**Fax Number:** (202)315-3758

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 202-429-0020 Email: pto@nsiplaw.com

Correspondent Name: NSIP LAW

Address Line 1: P.O. BOX 65745

Address Line 4: WASHINGTON, D.C. 20035

ATTORNEY DOCKET NUMBER:	023103.0209
NAME OF SUBMITTER:	WALE T. GODO
SIGNATURE:	/Wale T. Godo/
DATE SIGNED:	09/04/2019

## **Total Attachments: 2**

source=NewApp\_0231030209\_CDA\_EPAS#page1.tif source=NewApp\_0231030209\_CDA\_EPAS#page2.tif

PATENT 505653878 REEL: 050264 FRAME: 0092

## COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

#### DECLARATION

As a below-named inventor, I hereby decor to United States Application Number of		
filed on _	(if app	licable), entitled:
	AVING DEEP TRENCH STRUCTU ANUFACTURING THEREOF	JRE AND METHOD OF
The above identified application was made	de or authorized to be made by me	

The above-identified application was made or authorized to be made by me.

I believe I am the original inventor or an original joint inventor of a claimed invention in the above-identified application.

I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 USC 1001 by fine or imprisonment of not more than five (5) years, or both.

I have reviewed and understand the contents of the above-identified application, including the claims.

I am aware of the duty to disclose to the United States Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR 1.56, including for continuation-in-part applications, material information that became available between the filing date of the prior application and the national or PCT international filing date of the continuation-in-part application.

#### **ASSIGNMENT**

For valuable consideration, I, as a below-named assignor, hereby assign to:

MagnaChip Semiconductor, Ltd. 215, Daesin-ro, Heungdeok-gu Cheongju-si, Chungcheongbuk-do, 28429 Republic of Korea

and its su	ccessors and assigns (collective	vely hereina	fter called "the Assignee"), the entire right, title, and
interest th	nroughout the world in the inver	ntions and ir	mprovements that are the subject of the application
identified	in the above declaration, which	r is United S	States Application Number or PCT International Application
Number	16/560,147	filed on	September 4, 2019

I authorize and request the attorneys appointed in the above-identified application to hereafter complete this Assignment by inserting above the application number and the filling date of the above-identified application when known, and to correct any typographical errors that may be discovered in this Assignment.

This Assignment includes the above-identified application, any and all continuation applications and divisional applications claiming the benefit of the above-identified application under the United States patent laws, any and all United States and foreign patents, utility models, and design registrations granted for any of the inventions and improvements that are the subject of the above-identified application, and the right to claim priority based on the filing date of the above-identified application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and I authorize the Assignee to apply in all countries in my name or in its own name for patents, utility models, design registrations, like rights of exclusion, and inventors' certificates for any of the inventions and improvements that are the subject of the above-identified application; and I agree for myself and my heirs, legal representatives, and assigns without further compensation to perform such lawful

# COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

acts and to sign such further applications, Assignments, preliminary statements, and other lawful documents as the Assignee may reasonably request to effectuate fully this Assignment.

In witness whereof, I, as a below-named inventor and assignor, intending to be legally bound, have hereunto affixed my signature on the date indicated below next to my signature.

inventor's Legal Name	Yang Beom KANG		
Inventor's Signature	dh	Date	8/21,2019
Residence (City, Country)	Cheongju-si, Republic of Korea		· · · · · · · · · · · · · · · · · · ·
Mailing Address	c/o MagnaChip Semiconductor Ltd., 215, Daesin-ro, Heungduk-gu, Cheongju-si, Chungcheongbuk-do, 28429, Republic of Korea		

Inventor's Legal Name	Kang Sup SHIN			
Inventor's Signature	h/W	Date	8/2/	10
Residence (City, Country)	Cheongju-si, Republic of Korea		, ,	
Mailing Address	c/o MagnaChip Semiconductor Ltd., 215, Daesin-ro, Heungduk-gu, Cheongju-si, Chungcheongbuk-do, 28429, Republic of Korea			